

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Seiji TAI, et al.

Filed: February 25, 2004

For: PROCESS FOR PREPARING PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL, PHOTOSENSITIVE ELEMENT FOR FIELD EMISSION DISPLAY PANEL, PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL AND FIELD EMISSION DISPLAY PANEL

Expected Group: 1756

Expected
Examiner: J. McPherson

CLAIM FOR PRIORITY

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 25, 2004


Sir:

Pursuant to the provisions of 35 USC 119 and 37 CFR 1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 09-132254, filed in Japan on May 22, 1997.

A certified copy of the above-identified Japanese Patent Application was submitted on August 11, 1998, in prior application Serial No. 09/083,057, filed May 22, 1998.

Respectfully submitted,

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